



Science and Technology of Materials, Interfaces, and Processing

Topical Areas

Biomaterials
Environmental S&T
Magnetic Materials
Manufacturing S&T
Materials Characterization
Materials Processing
MEMS
Microelectronic Materials
Nanometer-Scale S&T
Plasma S&T
Surface Engineering
Surface Science
Thin Films
Vacuum Technology

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Exhibition
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Finance
212-248-0200, ext. 224

Marketing/Meetings
530-896-0477

Member Services
212-248-0200, 221

Publications
919-361-2787

Short Courses
530-896-0477

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212-248-0200, ext. 223

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Press Invitation

We hope that you will join us at the AVS 57th International Symposium and Exhibition being held October 17-22, 2010, at the Albuquerque Convention Center, in Albuquerque, New Mexico.

More than 1,200 abstracts in all areas of materials, processing, and interfaces, including biomaterials interfaces, thin films, electronics, and nanotechnology, will be presented at this weeklong technical symposium. In addition, the symposium will feature 150-plus exhibitors showing the most advanced equipment and services available in these fields.

The AVS Pressroom will be located in Albuquerque Convention Center. Pressroom hours are: Monday-Thursday, 8:00-5:00 p.m.

Your press badge will allow you to utilize the pressroom to write, interview, collect new product releases, review material, or just relax. The press badge will also admit you, *free of charge*, into the exhibit area, lectures, and technical sessions, etc. It will also admit you into the Welcome Mixer on Monday Evening as well as the Awards Ceremony and Reception on Wednesday night.

The Technical Program containing all symposium and exhibition details, including travel information may be found on the AVS Website in late July at www.avs.org.

To register (complimentary) as a member of the press, please complete the attached form and fax or e-mail by October 10 to: Della Miller, AVS, fax 530-896-0487, della@avs.org.

While pre-registration is not mandatory, this will enable us to prepare your registration packet and press badge in advance.

You may pick up your press badge in the main registration area from Sunday-Thursday. Press Kits containing exhibiting company's new product announcements and other news will be available on CD-ROM in the pressroom.

AVS Press Registration Form

AVS 57th International Symposium and Exhibition

October 17-22, 2010

Albuquerque Convention Center, Albuquerque, New Mexico

Preregister by October 10, 2010

Name: _____

Title: _____

Name of Publication(s): _____

Address: _____

Phone: _____ Fax: _____

E-mail: _____

Press Kit Preferences

- I prefer to pick up my press kit in the pressroom at the conference (CD-ROM)
- I prefer to receive my press kit after the conference (CD-ROM)

Attendance Plans

- Yes, I plan to attend the Plenary Lecture
- Yes, I plan to attend the Welcome Mixer
- Yes, I plan to attend some of the Exhibitor Technology Spotlights throughout the week
- Yes, I will be available to schedule appointments with exhibitors upon request